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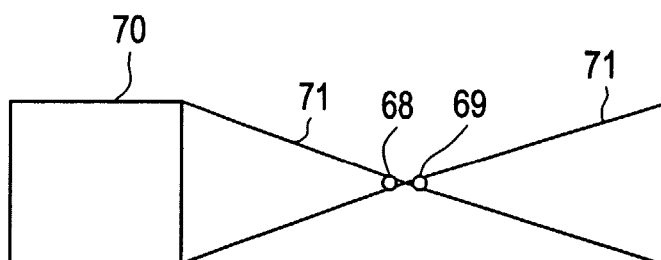
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(54) Title: OPTICAL TOOLS MANIPULATED BY OPTICAL TRAPS



(57) Abstract: Micrometer and nanometer-sized tools (69), referred to as MOTS and NOTS, respectively, are manipulated in the illumination (71) of an optical trap (70) and are able to alter the physical, chemical or electronic structure or orientation of a workpiece (68).



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